

Model : FLA-200

Semi-automatic non-contact wafer flatness measurement system



Measures Thickness, TTV, Bow, Warp and site and global Flatness (ASTM compliance) by Non-contact

Features

- Measures Thickness, TTV, Bow, Warp and site and global Flatness (ASTM compliance)
- High accurate 5 mm in diameter core capacitance sensors
- Full 500 micron thickness measurement range without re-calibration
- Max. 12,000 sites measurement in 1 minute
- 2-D /3-D Mapping software
- Measurement data base link with Excel via CSV format file

Applications

- Material : All semiconducting and semi-insulating wafers including Si, GaAs, Ge, InP
- Surfaces: As-Cut, Lapped, Etched, Polished, Patterned
- Flat/Notch : All SEMI Standard Flat(s) or Notch
- Wafer Mounting : Bare Wafer, Sapphire/Quartz base, tape

Sample Sizes

Size : 75 ~ 200mm(3 ~ 8inch)

Thickness : ~ 2mm

Measurement Range

Measurement Item	Measurement Range
Thickness	200 ~ 1200 μm
BOW	+/- 350 μm
WARP	350 μm

<Site data> Thickness (Center, Max, Min, Ave), SBID, SBIR, SF3D, SF3R, SFLD, SFLR, SFQD, SFQR

<Global data> GF3D, GF3R, GFLD, GFLR, Bow-3P, Bow-BF, Warp-3P, Warp-BF, Sori-3P, Sori-BF, FPD%, Taper, Roll off

A global leading company for resistivity measurement system.



Software Function

- Measurement result can be displayed by 2-D / 3-D map graphic.
- Mapping graphic can be saved by JPEG file.

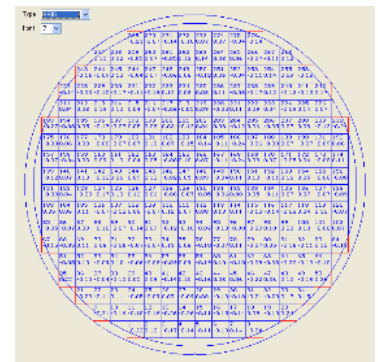
Site No.	Center Position		Thickness				SBID	SBIR	SF3D	SF3R	SFLD	SFLR	SFQD	SFQR
	X	Y	Center	Max	Min	Ave								
1	-35.00	-85.00	748.00	748.21	747.78	747.98	-0.22	0.43	-0.22	0.40	-0.23	0.41	0.02	0.03
2	-25.00	-85.00	748.21	748.33	748.15	748.23	0.12	0.18	0.10	0.19	0.11	0.19	-0.03	0.06
3	-15.00	-85.00	748.16	748.26	747.99	748.14	-0.17	0.26	-0.14	0.20	-0.15	0.21	-0.02	0.03
4	-5.00	-85.00	748.06	748.12	747.92	748.01	-0.14	0.20	-0.13	0.17	-0.14	0.18	0.02	0.03
5	5.00	-85.00	748.05	748.09	747.94	748.03	-0.11	0.15	-0.14	0.20	-0.14	0.21	0.03	0.05
6	15.00	-85.00	748.10	748.12	748.00	748.08	-0.10	0.12	-0.07	0.11	-0.08	0.12	-0.04	0.05
7	25.00	-85.00	747.98	748.11	747.93	748.01	0.14	0.18	0.11	0.15	0.11	0.16	0.02	0.03
8	35.00	-85.00	747.97	748.10	747.82	747.84	-0.24	0.47	-0.26	0.51	-0.27	0.52	0.03	0.05
9	-85.00	-75.00	748.45	748.66	748.23	748.44	-0.21	0.42	0.20	0.39	0.21	0.41	-0.03	0.04
10	-45.00	-75.00	748.43	748.54	748.27	748.43	-0.16	0.26	-0.14	0.22	-0.15	0.23	0.04	0.08
11	-35.00	-75.00	748.44	748.53	748.35	748.45	-0.10	0.19	0.12	0.19	0.12	0.19	-0.02	0.04

Thickness	Judgment	Item	Judgment
Center	NG	SFFOK	46.01
Maximum	NG	SBID	OK
Minimum	NG	SBIR	OK
Average	NG	SF3D	OK
		SF3R	NG
		SFLD	OK
		SFLR	NG
		SFQD	OK
		SFQR	OK

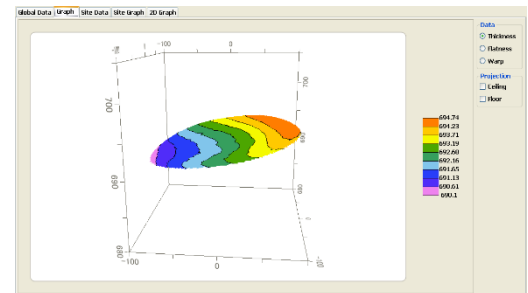
Item	Data	Judgment
SFFOK	46.01	OK
STPRK	100.00	NG

Image

Software : Main



Site data image



2-D map graphic

Measurement Accuracy / Repeatability

Measurement Item	Accuracy	Repeatability
Thickness (ASTM F533)	+/-0.5μm	0.15μm
TTV (ASTM F657)	+/-0.5μm	0.15μm
Bow (ASTM F534)	+/-3μm	1μm
Warp (ASTM F1390)	+/-3μm	1μm
Flatness [site] (ASTM F1530)	+/-0.15μm	0.05μm
Flatness [global] (ASTM F1530)	+/-0.15μm	0.05μm

*Repeatability = σ (10 times measurement)

*Site size X,Y = Select from 8 mm ~ 30 mm settings (by 0.1mm unit)

Throughput (Tact time)

Measurement Sites	Throughput
12,113 sites (4mm spacing)	approx. 58 sec
10,111 sites (5mm spacing)	approx. 53 sec
5,406 sites (10mm spacing)	approx. 41 sec

*Throughput will change by setting conditions, resistance value and the sample surface state.

*Please contact us for more details.

*The customers are always welcome to do Demo measurement.

*Specification subject to change without notice.